

PATENT  
Docket No. 29284/495

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of : Yasuhiko NARA et al.  
Serial No. : 09/450,856  
Filed : 29 November 1999  
For : INSPECTION METHOD, APPARATUS AND SYSTEM FOR  
CIRCUIT PATTERN  
Group Art Unit : 2877

ASSISTANT COMMISSIONER  
FOR PATENTS  
Washington, DC 20231

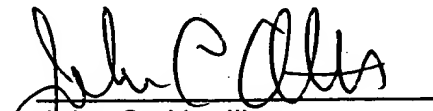
CLAIM TO CONVENTION PRIORITY UNDER 35 U.S.C. § 119

SIR:

Applicants hereby claim the Convention Priority Dates of Japanese Patent Applications Nos. 10-340292, 10-340293, 10-340294, 10-340295, 10-340296, and 10-340297, all filed 30 November 1998, and No. 10-367710 filed 24 December 1998, respectively. To complete the claim to the Convention Priority Dates, certified copies of said Japanese Patent Applications are submitted herewith.

Respectfully submitted,

Dated: 11 February 2000

  
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